



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasushi OKUBO et al.

Group Art Unit: 1795

Application No.: 10/551,136

Examiner: S. ROSASCO

Filed: January 5, 2006

Docket No.: 125493

For: MASK BLANK, MANUFACTURING METHOD OF MASK BLANK,
MANUFACTURING METHOD OF TRANSFER MASK AND MANUFACTURING
METHOD OF SEMICONDUCTOR DEVICE

AMENDMENT FILED WITH RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the October 19, 2009 Office Action, and in consideration of the attached Request for Continued Examination (RCE), please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.

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